

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

#2
PRE
Amend
A
3/9/99

In re Application of:

Docket No.: TI-27935

Bailey et al.

Group: To Be Determined

Serial No: To Be Determined

Examiner: To Be Determined

Filed: Herewith

For: Method of Producing a Thin Film Resistor in an Integrated Circuit

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Please amend the above-referenced application as follows:

IN THE SPECIFICATION:

Page 1, before the first line of the first paragraph, insert --This application claims priority under 35 USC 119(e)(1) of provisional application number 60/112,731 filed 12/18/98.--

REMARKS

Entry of the foregoing amendment prior to examination is respectfully requested.

If the Examiner has any questions or other correspondence regarding this application, Applicant requests that the Examiner contact Applicant's attorney at the below listed telephone number and address.

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Respectfully submitted,



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